



NEG coatings and Laser Ablation Surface Engineering (LASE) electron cloud mitigation techniques

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The University of Manchester



EuroCirCol Task 4.3: Mitigate beam-induced vacuum effects

*ASTeC Vacuum Science Group,
STFC Daresbury Laboratory, UK*



FCC Week 2018, 9-13 April 2018,
Beurs van Berlage, Amsterdam, Netherlands



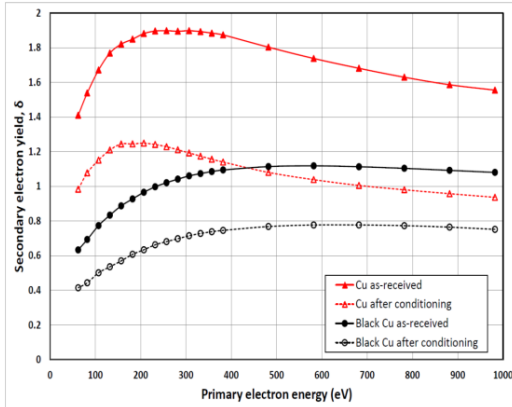
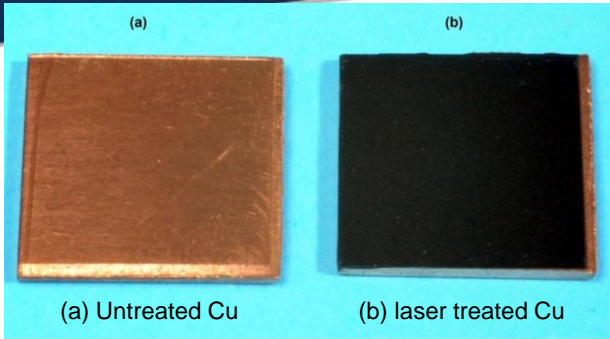


SEY studies:

e-cloud mitigation

**by reducing Secondary Electron Yield (SEY)
Laser Ablation Surface Engineering (LASE)**

Discovery of LASE for SEY mitigation



R. Valizadeh, et al. *Appl. Phys. Lett.* **105**, 231605 (2014); doi: 10.1063/1.4902993

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1. (WO2015189645) APPARATUS AND METHODS RELATING TO REDUCED PHOTOELECTRON YIELD AND/OR SECONDARY ELECTRON YIELD

PCT Biblio. Data Description Claims National Phase Notices Drawings Documents

Latest bibliographic data on file with the International Bureau PermaLink

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Publication Date:	17.12.2015	International Filing Date:	15.06.2015
IPC:	B23K 26/36 (2014.01), B23K 26/00 (2014.01)		
Applicants:	THE SCIENCE AND TECHNOLOGY FACILITIES COUNCIL [GB/GB]; Daresbury Laboratory Sci-Tech Daresbury, Daresbury Warrington WA4 4AD (GB)		
Inventors:	VALIZADEH, Reza; (GB); MALYSHEV, Oleg; (GB)		
Agent:	HGF LIMITED; 4th Floor, Merchant Exchange 17-19 Whitworth Street West Manchester M1 5WG (GB)		
Priority Data:	1410593.6 13.06.2014 GB		
Title	(EN) APPARATUS AND METHODS RELATING TO REDUCED PHOTOELECTRON YIELD AND/OR SECONDARY ELECTRON YIELD		

- Nanostructuring of Material Surfaces by Laser Ablation is well established science and manufacturing
- The new is applying these surfaces to suppress PEY/SEY and to solve the e-cloud problem
- Main result: SEY < 1 can be achieved on Cu, Al and stainless steel

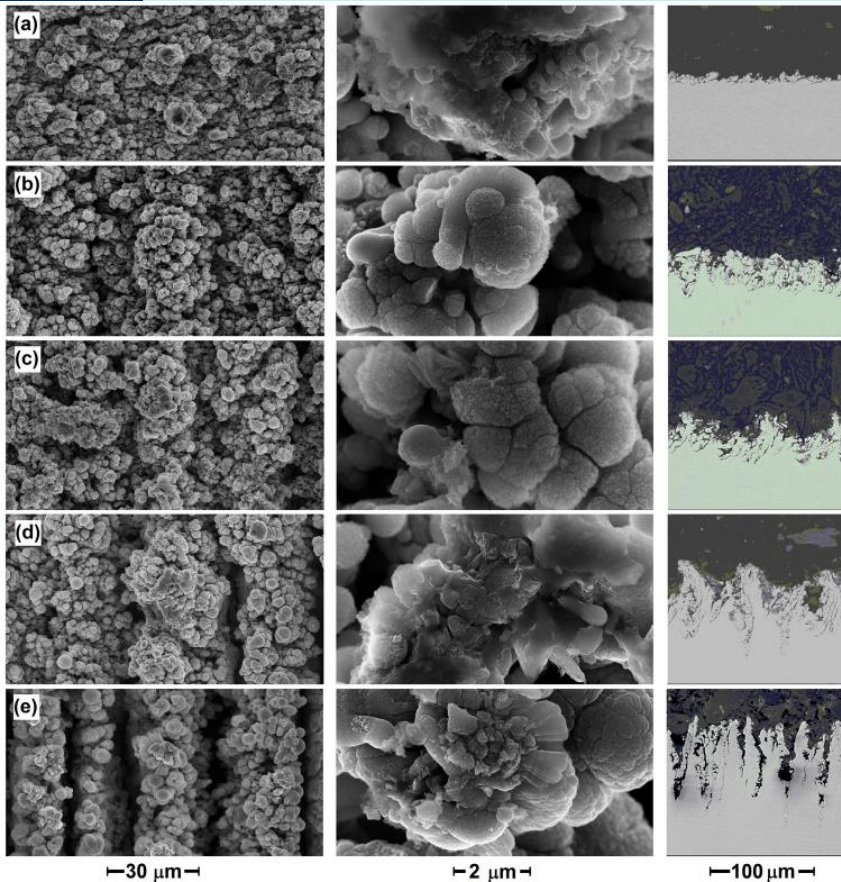


Recent low SEY studies

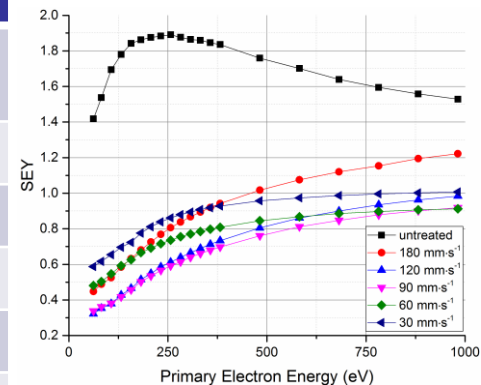
- Emphasis on the following problems:
 - How and why SEY is reduced on LASE surfaces
 - Reduce SEY with various lasers
 - Study an effect of cleaning
 - Study an effect of aging
 - Reduce surface resistance to minimise an impact on beam impedance
 - Reduce particulate generation
 - Apply for machine tests
- R. Valizadeh, O.B. Malyshev, S. Wang, et al. IPAC'16, p. 1089.
- R.Valizadeh, O.B.Malyshev, S.Wang, et al. Applied Surface Science 404 (2017) 370-379.
<http://dx.doi.org/10.1016/j.apsusc.2017.02.013>



A role of laser scan speed on copper samples



Sample	Scan speed [mm/s]	Groove depth [μm]	Rs [Ω]
	untreated	-	0.033
(a)	180	8	0.078
(b)	120	20	0.13
(c)	90	35	0.14
(d)	60	60	-
(e)	30	100	-



Treatment of copper using a $\lambda = 355$ nm laser resulted in creation of three different scales structures:

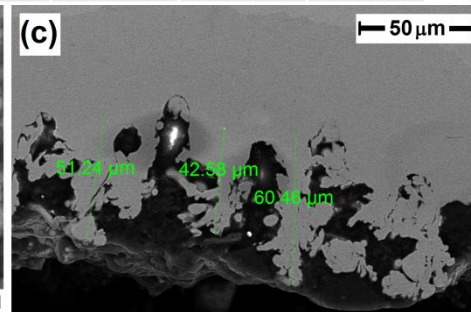
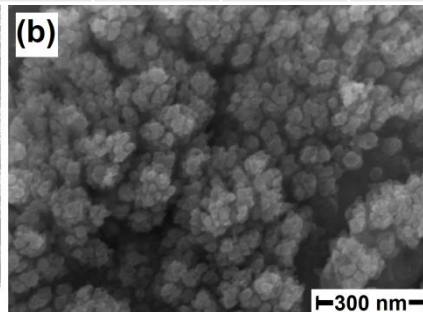
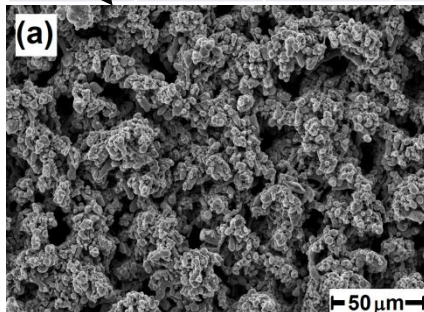
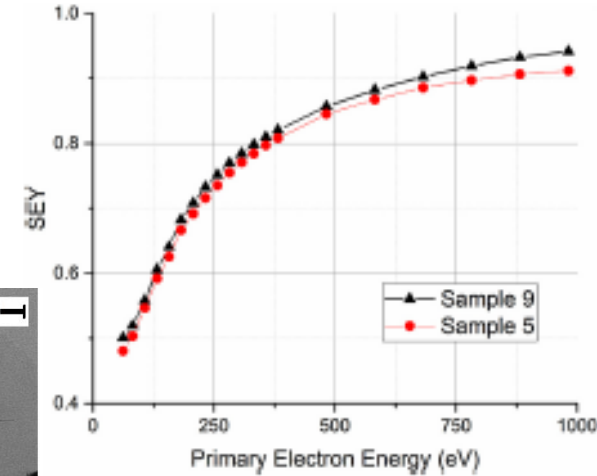
- microstructure grooves ranging from 8 to 100 μm deep,
- coral-like submicron particles superimposed on the grooves which is made of agglomeration of
- nano-spheres



A role of laser wavelength

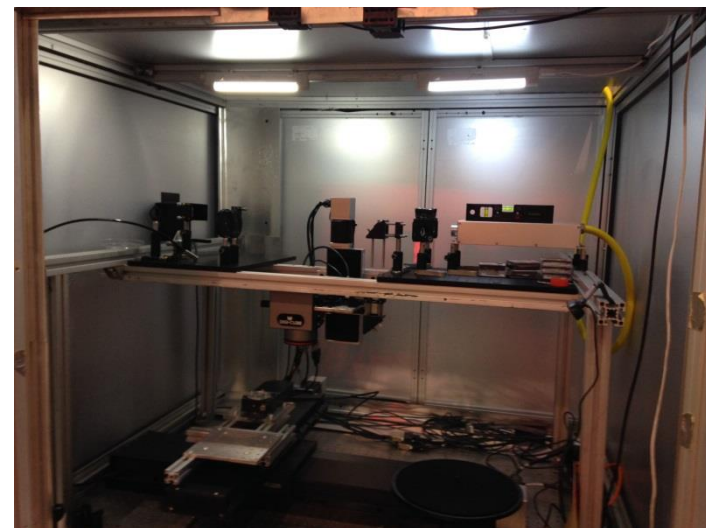
Similar surfaces with similar results for SEY can be produced using various lasers with different wavelengths, such as $\lambda=355$ nm and $\lambda=1064$ nm.

Sample	λ (nm)	Av. power (W)	Spot size (μm)	Pulse duration (ns)	f (kHz)	Pitch width (μm)	Scan speed (mm/s)	Energy per pulse (μJ)	Fluence (J/cm^2)
5	355	3	15	25	40	10	60	75	42
9	1064	3.6	25	70	10	20	30	360	73



Current work:

- More samples produced at Micronanics, Liverpool and Manchester Universities:
 - and being characterised on SEY and particulates
 - See posters:
 - *Taaj Sian*. New LASE surfaces obtained with various lasers and their parameters
 - *Reza Valizadeh*. A progress with further developing of laser ablating surface engineering (LASE) for e-cloud eradication in particle accelerator
 - A new Laser treatment facility was built



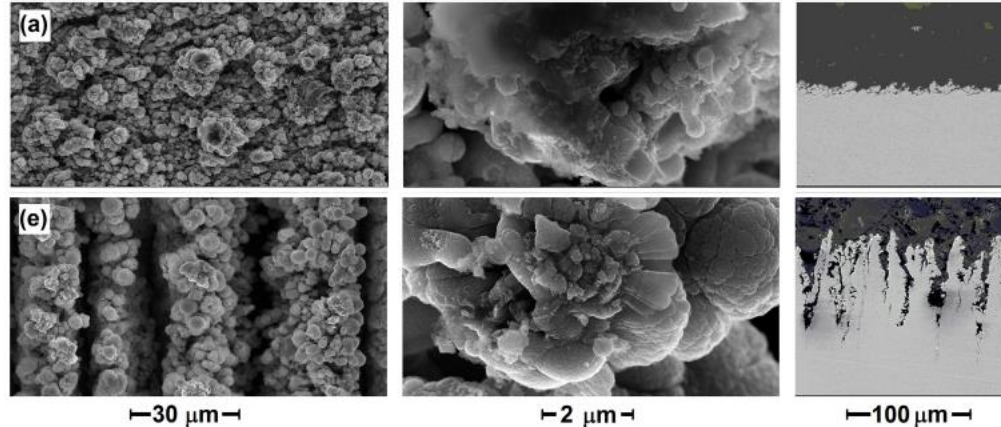
Samples produced with various lasers

Sample	λ (nm)	Average power (W)	Spot size (μm)	Pulse duration (ns)	Pulse repetition (kHz)	Pitch width (μm)	Scan speed (mm/s)	Energy per pulse (μJ)	Fluence (J/cm^2)
1	355	3	15	25	40	10	30	75	42
2	355	3	15	25	40	10	60	75	42
3	355	3	15	25	40	10	90	75	42
4	355	3	15	25	40	10	120	75	42
5	355	3	15	25	40	10	180	75	42
6	1064	1.9	25	70	2.5	20	125	760	154
7	1064	2.4	25	70	5.0	20	125	480	97
8	1064	3.6	25	70	10	20	30	360	73
9	1064	3	25	70	20	10	500	150	30
10	1064	1	25	70	100	10	500	10	2

Date		Wavelength	power	spotsizes	pulse duration	rep	pitch	speed	thickness		treatment	SEY
23/09/2015	Micronanics	355	3		2ns	40 kHz	5	120	50 micron thick			1.04
24/09/2016		355	3		2ns	40 kHz	5	120	100 micron thick			1.08
25/09/2016		355	3		2ns	40 kHz	5	90	100 micron thick			0.99
01/10/2016		355	3		2ns	40 kHz	5	90	50 micron thick			1.04
07/10/2015		355	3		2ns	40 kHz	5	90	50 micron thick		after acetone	1.01
08/10/2015		355				40 kHz		90				0.94
30/10/2015	Micronanics	355	3					90				0.815
02/11/2016		355	5					162				0.896
02/11/2015		355	5					216				1.125
03/11/2015		355	3					120				0.936
04/02/2016	Chester Uni	1064	5	15	>5ps	100 kHz	5	30				0.921
		1064	5	15	>5ps	100 kHz	5	30			after acetone	1.029
		1064	5	15	>5ps	100 kHz	5	5				0.922
		1064	5	15	>5ps	100 kHz	5	5			after acetone	0.925
29/03/2016		1064	5	15	>5ps	100 kHz	5	5	Argon atmosphere			0.872
14/02/2017	Micronanics	1064	5		70 ns	100 kHz	5	100				0.86
15/02/2017		1064	5		70 ns	100 kHz	10	100				0.94
20/02/2017		1064	5		70 ns	100 kHz	5	200				0.93
23/02/2017		1064	5		70 ns	100 kHz	10	200				1.06
	Micronanics with air flow											
08/03/2017	b	1064	6.6				10	30	air	no glass		1.01
	c	1064	6.6				10	30	pump flow (Flow of air)	glass		1.24
	d	1064	6.6				10	30	pump flow (Flow of air)	no glass		0.79
	e	1064	6.6				10	30	compressed air	no glass		0.99
	f	1064	6.6				10	30	compressed air	glass		1.31
20/06/2017	Manchester Uni	355nm	65	23 um	2ps	404 kHz	100	100				1.28
20/06/2017		355nm	65	23 um	2ps	404 kHz	100	200				1.59
21/06/2017		355nm	65	23 um	2ps	404 kHz	100	25				0.97
21/06/2017		355nm	65	23 um	2ps	404 kHz	100	50				1.09
22/06/2017		355nm	65	23 um	2ps	404 kHz	50	200				1.1
23/06/2017		355nm	65	23 um	2ps	404 kHz	25	100				0.82
23/06/2017		355nm	65	23 um	2ps	404 kHz	50	100				1.144
23/06/2017		355nm	65	23 um	2ps	404 kHz	25	200				1.135
23/06/2017		355nm	65	23 um	2ps	404 kHz	100	25				1.01
14/09/2017	IPG 40 kHz Miconanics	1064	20		2ns	40kHz	0.02	40				1.1
14/09/2017		1064	20		2ns	40kHz	0.02	80				1.17
19/09/2017		1064	10.5		2ns	40kHz	0.02	40				1.125

Main results

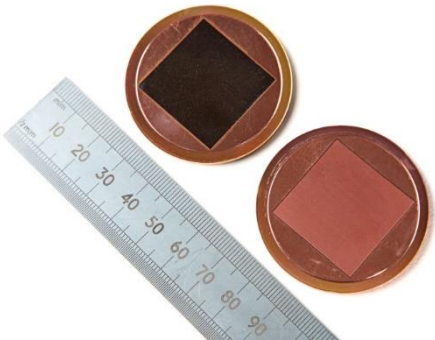
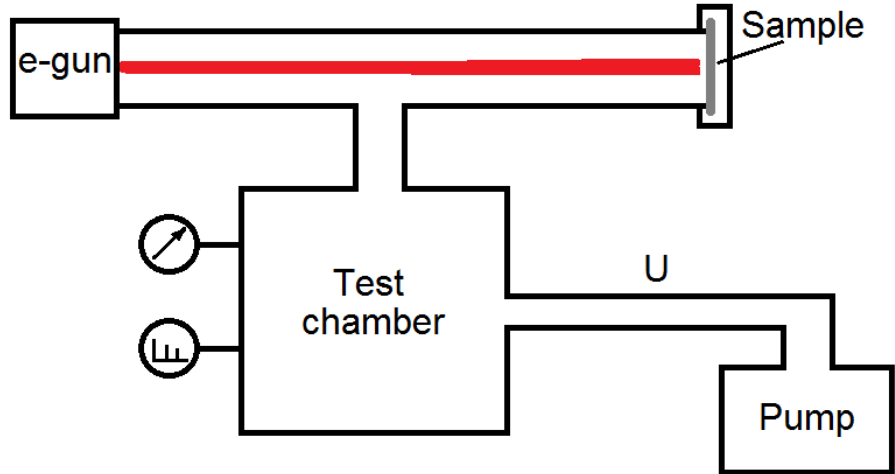
- SEY reduction due to a superposition of
 - microstructure (groves)
 - sub-micron and nano-structures



- Groves are main source in surface resistance.
- Low SEY surfaces can be produced using various lasers with different wavelength, such as $\lambda=355$ nm and $\lambda=1064$ nm, different power, with a variety of other parameters.



ESD measurements

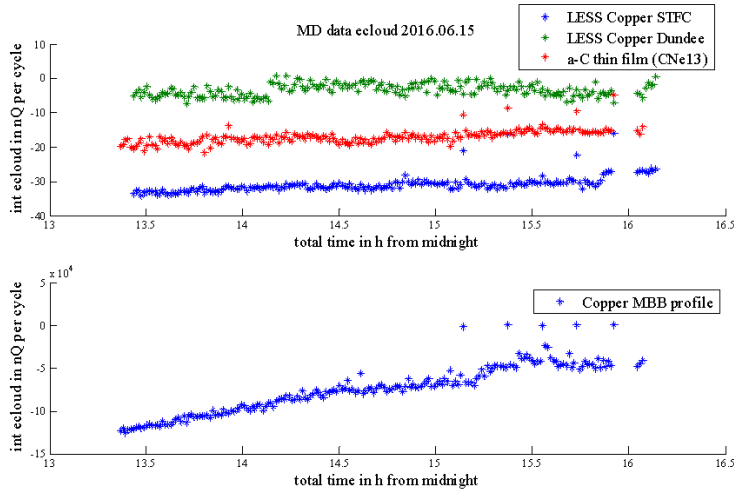
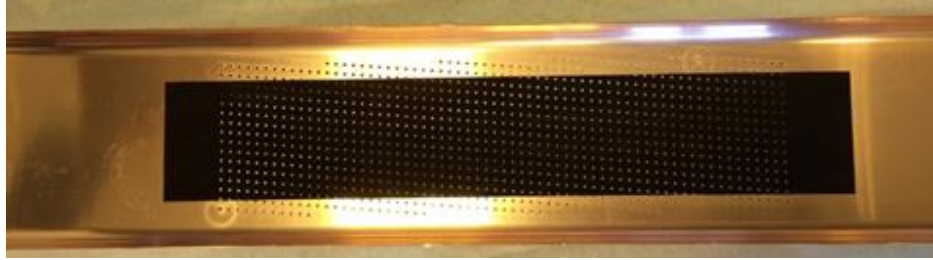
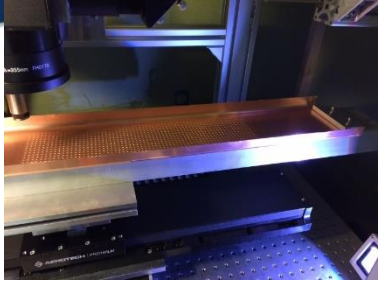


Particle counts





Test in SPS



- **Electron cloud mitigation has based on LASE has been successfully demonstrated in particle accelerator for the first time**

- S. Calatroni, et al. First accelerator test of vacuum components with laser-engineered surfaces for e-cloud mitigation. Phys. Rev. Acc. and Beams 20, 113201 (2017).

Laser treated samples for WP4 partners

- 1) 10 samples for INFN to study an effect of cryogenic temperatures and crysorbed gases on SEY
 - see a poster R. Cimino et al.
 - treated area 8 mm x 8 mm; Laser 355 nm or 1064 nm.
- 2) A sample for a reflectivity study at BESSY
 - See a poster E. La Francesca, R. Cimino. et al.)
 - Treated area 20 mm x 300 mm.
 - Laser 1064 nm.
- 3) 4 samples for BINP, Novosibirsk (A. Krasnov)
 - 12 mm x 12 mm; Laser 355 nm or 1064 nm.

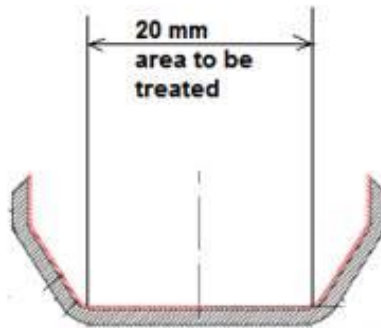
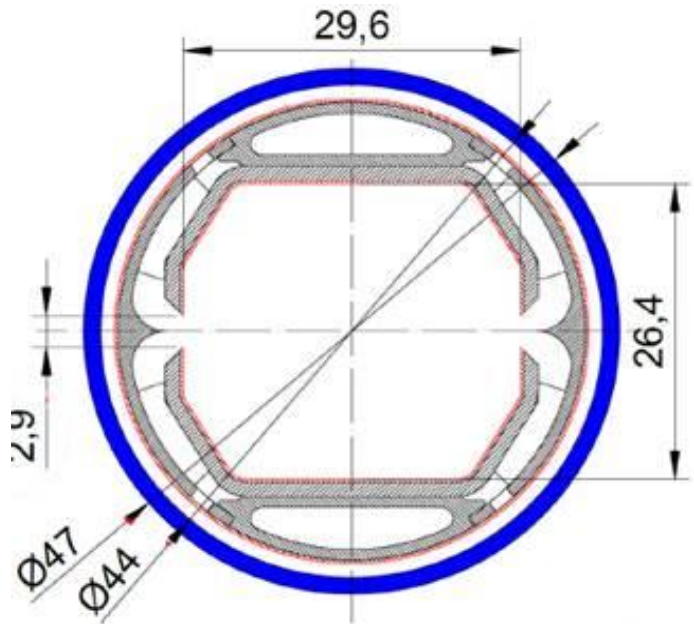


All samples have being laser treated at Micronanics

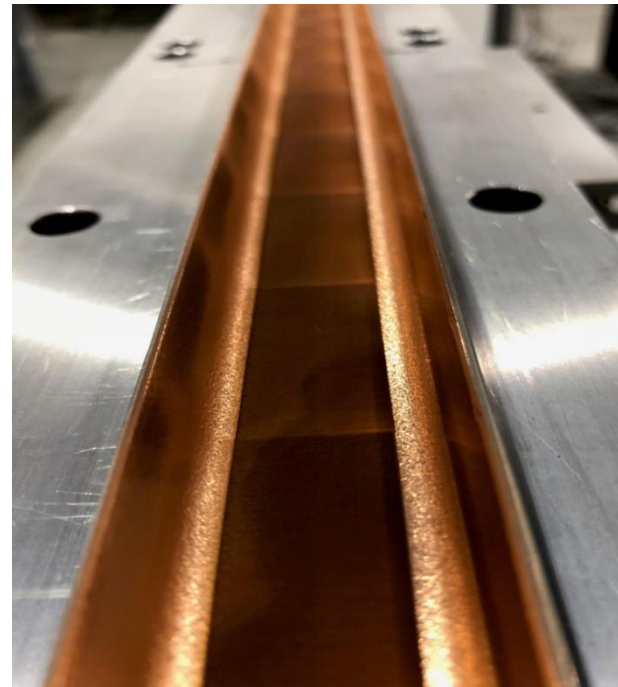


Laser treated samples for WP4 partners

4) Sample for KARA experiment in ANKA (KIT) – 2 m long a tube in two halves, treated area of each half is 2 m x 20 mm. Laser 1064 nm.

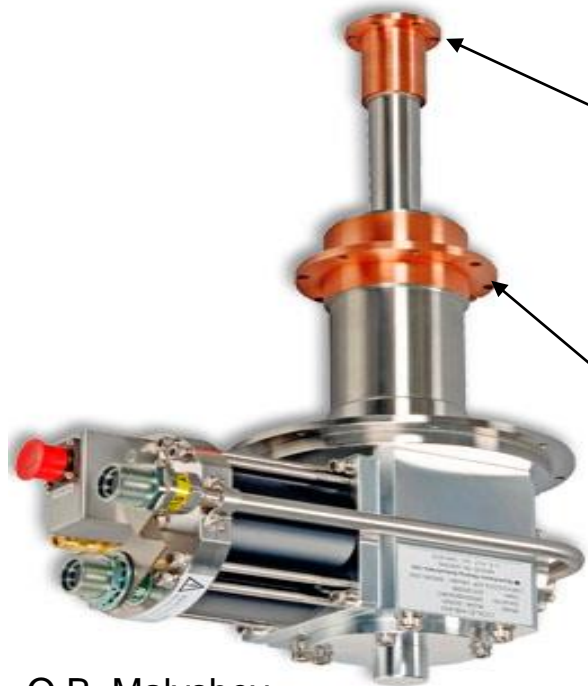


two samples with
total area to be laset treated
2 x 20 mm x 2 m



A new cryogenic temperature facility

RDK-305D 4K Cryocooler
(RDK-305D Cold Head with
CNA-31C/D Compressor)



Bellows

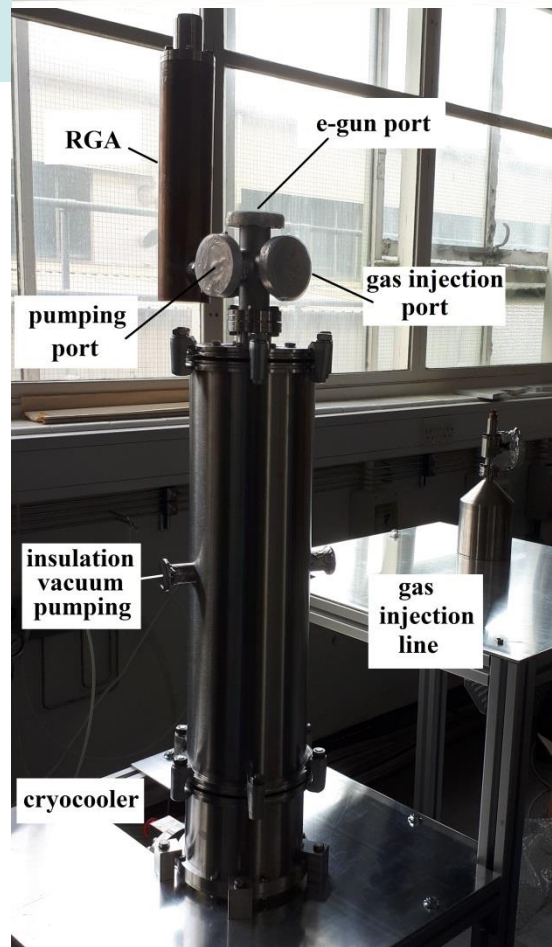
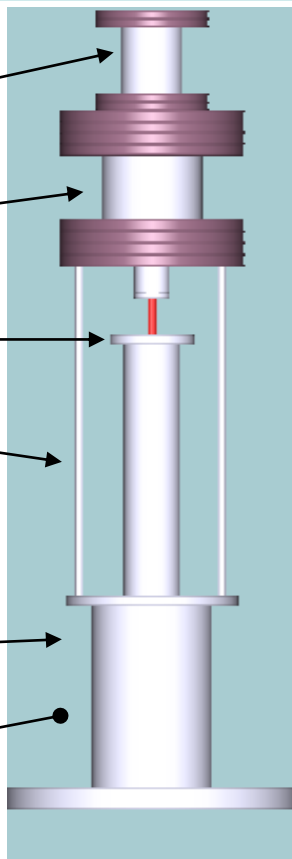
Test chamber

2nd stage

Conductor
from 1st stage to
heat shield

1st stage

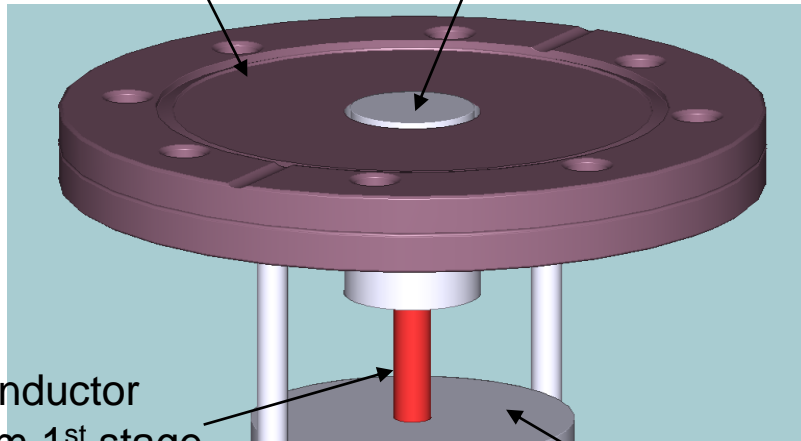
Insulation
vacuum



A new cryogenic temperature facility

Bottom flange
of test chamber
at 60-80 K

Sample at 4-80 K



Conductor
from 1st stage
to a sample

2nd stage

- Current work:
 - Assembling a facility for cryogenic measurements
- Next Steps:
 - Completing assembly
 - Testing
 - Measurements at $4\text{ K} < T < 80\text{ K}$
 - No condensed gas
 - With condensed gas
 - See a posters:
 - *Taaj Sian*. A facility for studying SEY from LASE surfaces at cryogenic temperatures



NEG coating studies



What NEG coating does

1) Reduces gas desorption:

- A pure metal (Ti, Zr, V, Hf, etc.) film ~1- μm thick without contaminants.
- A barrier for molecules from the bulk of vacuum chamber.

2) Increases distributed pumping speed, S :

- A sorbing surface on whole vacuum chamber surface

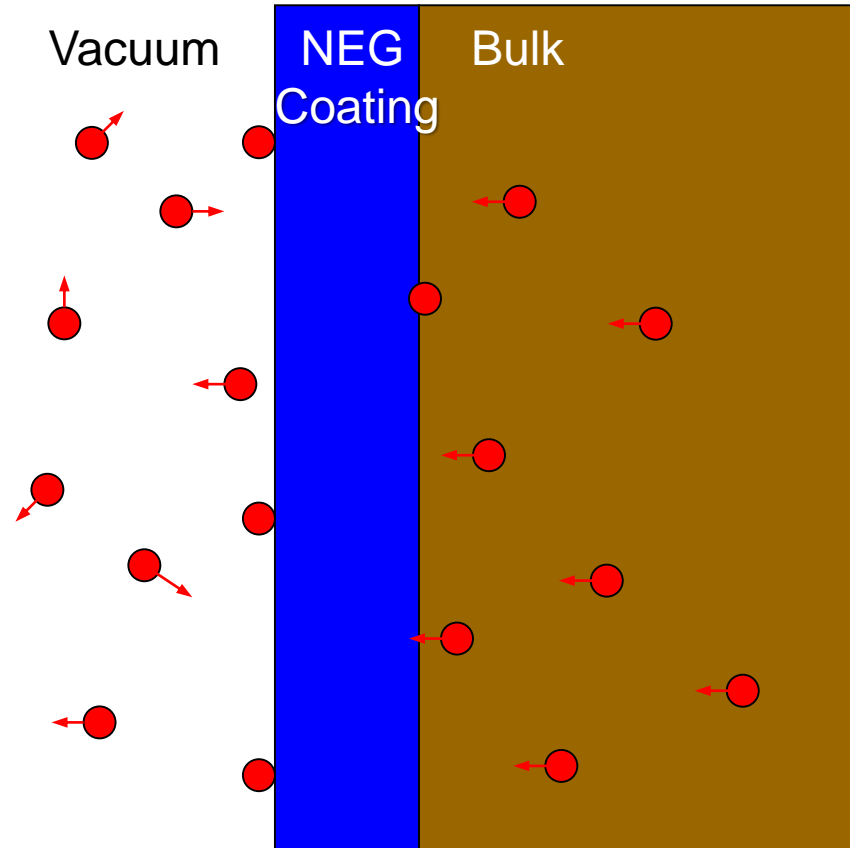
$$S = \alpha \cdot A \cdot v / 4;$$

where

α – sticking probability,

A – surface area,

v – mean molecular velocity

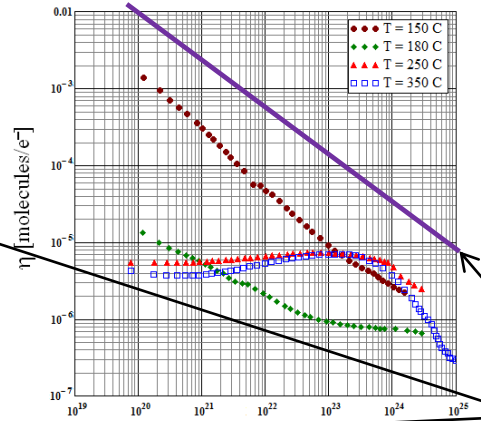
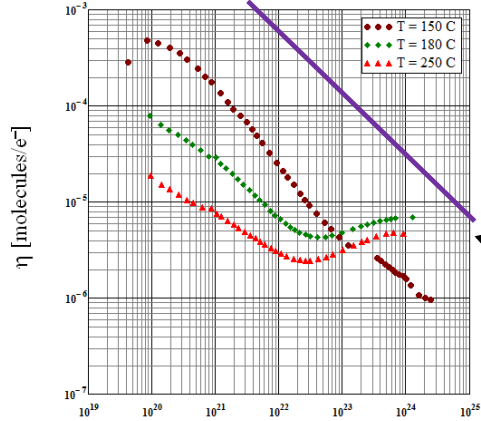


Electron stimulated desorption of H₂

(a) Columnar film

(b) Dense film

Vacuum fired

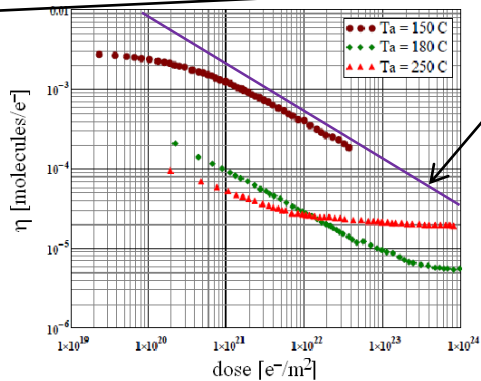
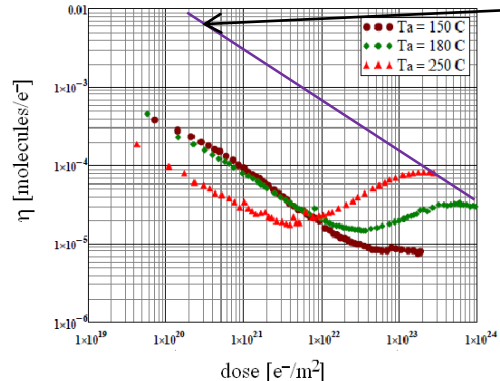


$$P \propto \frac{\eta}{\alpha} = \frac{\text{desorption yield}}{\text{sticking probability}}$$

- H₂ ESD is much lower than for 316 LN
- Distributed pumping
 - => low pressure

316LN
T_b=250°C

No vacuum firing



O.B. Malyshev, R. Valizadeh, et al. JVST A 32, 061601 (2014)



NEG coating for FCC-hh

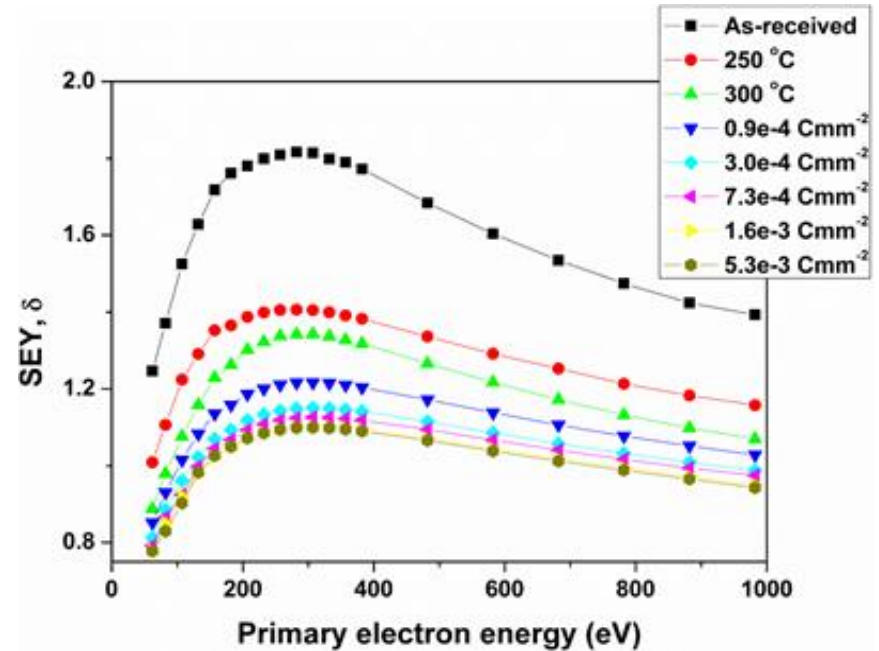
- Looking for new materials
 - Lower activation temperature
 - It is 150 °C for columnar Ti-Zr-Hf-V.
 - Effect of photon and electron induced activation
 - It is possible to avoid NEG activation by heating?
- NEG coating at cryogenic temperatures
 - Reduced PSD and ESD
 - Impact on PEY and SEY
- NEG coating surface resistance
 - Developing new materials with higher electric conductivity
 - Effect of temperature



What NEG coating does

3) Reduces SEY:

- After NEG activation
- After beam conditioning



S. Wang. PhD Thesis

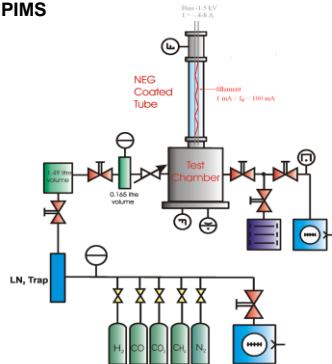
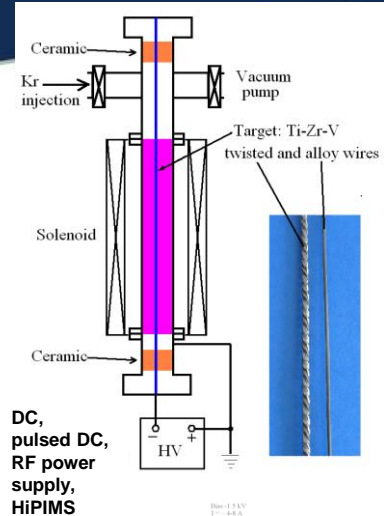
NEG coating studies

- **Current work:**

- **Studying pure Zr film on a sample tubes, ESD and pumping measurements**
 - Three samples (dense and columnar film) measurements and data analysis completed.
 - See a poster of Ruta Sirvinskaite. Single metal Zr NEG coating, its pumping properties and electron stimulated desorption
- **Four other sample with different materials have been deposited**
 - One sample – pumping properties completed
 - Others will be studied over next two months

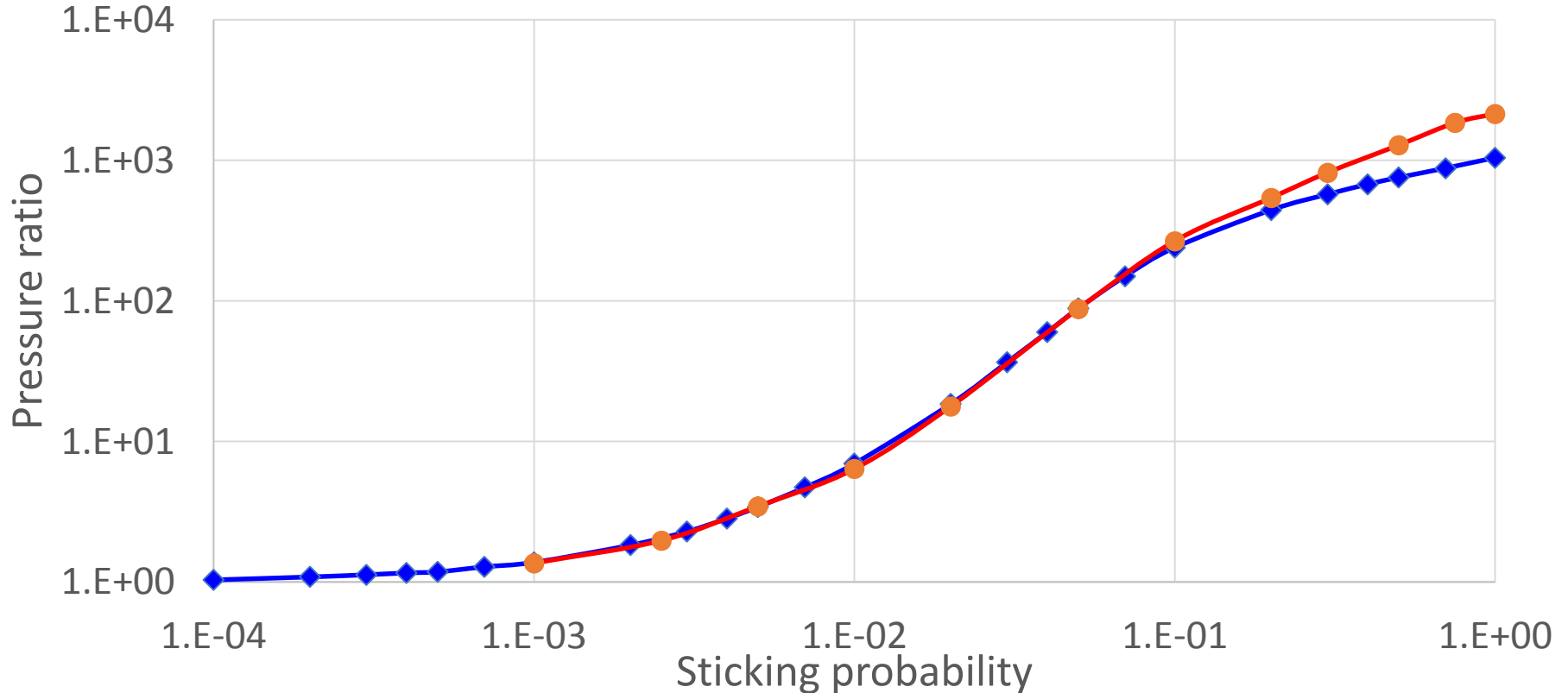
- **Next Steps:**

- **Assemble a facility for cryogenic (LN₂) measurements and start a cryogenic study**
- **Design of a facility for cryogenic (dry system 4 K < T < 80 K) measurements**
- **Analysis of the experimental results**

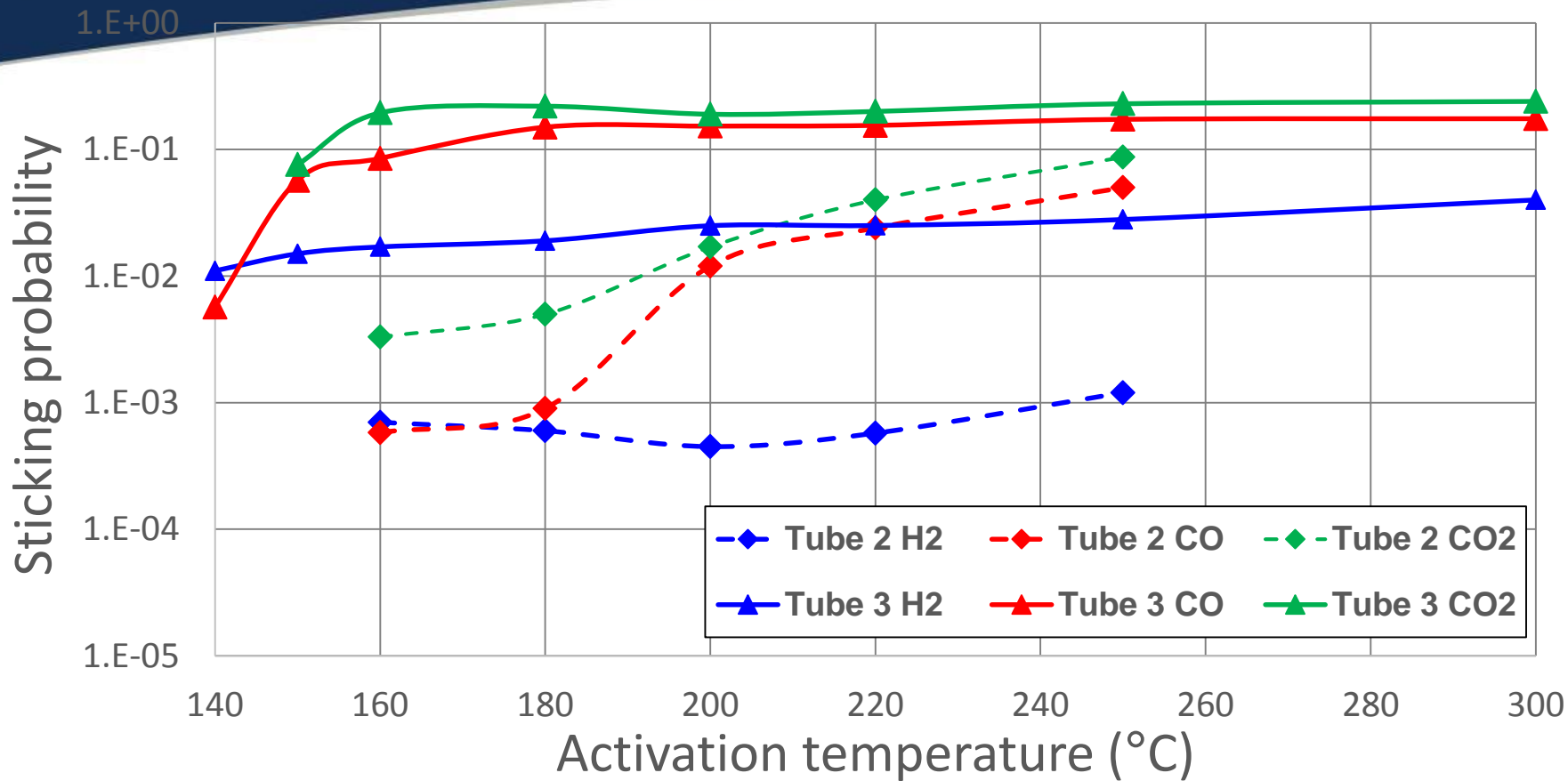




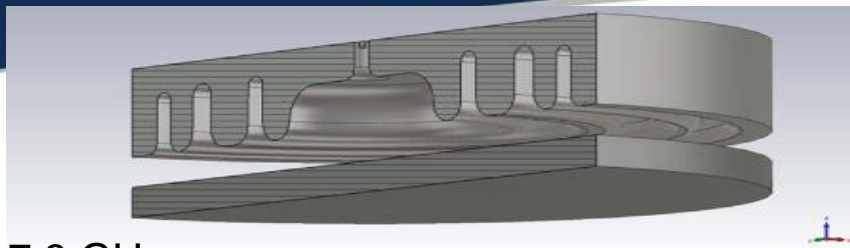
Modelled pressure ratio vs. sticking probability



Sample 2 - dense Zr, sample 3 - columnar Zr



How do we measure the surface resistance

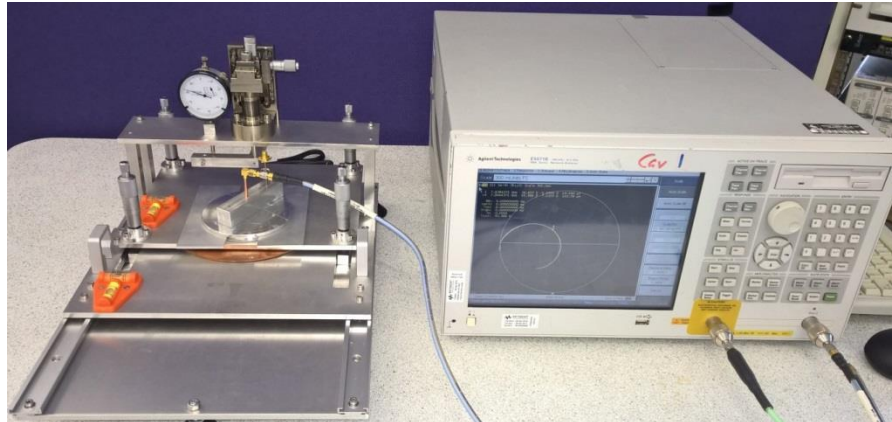


$f = 7.8 \text{ GHz}$

Fig. 1. A schematic of the triple choke RF cavity above a sample.

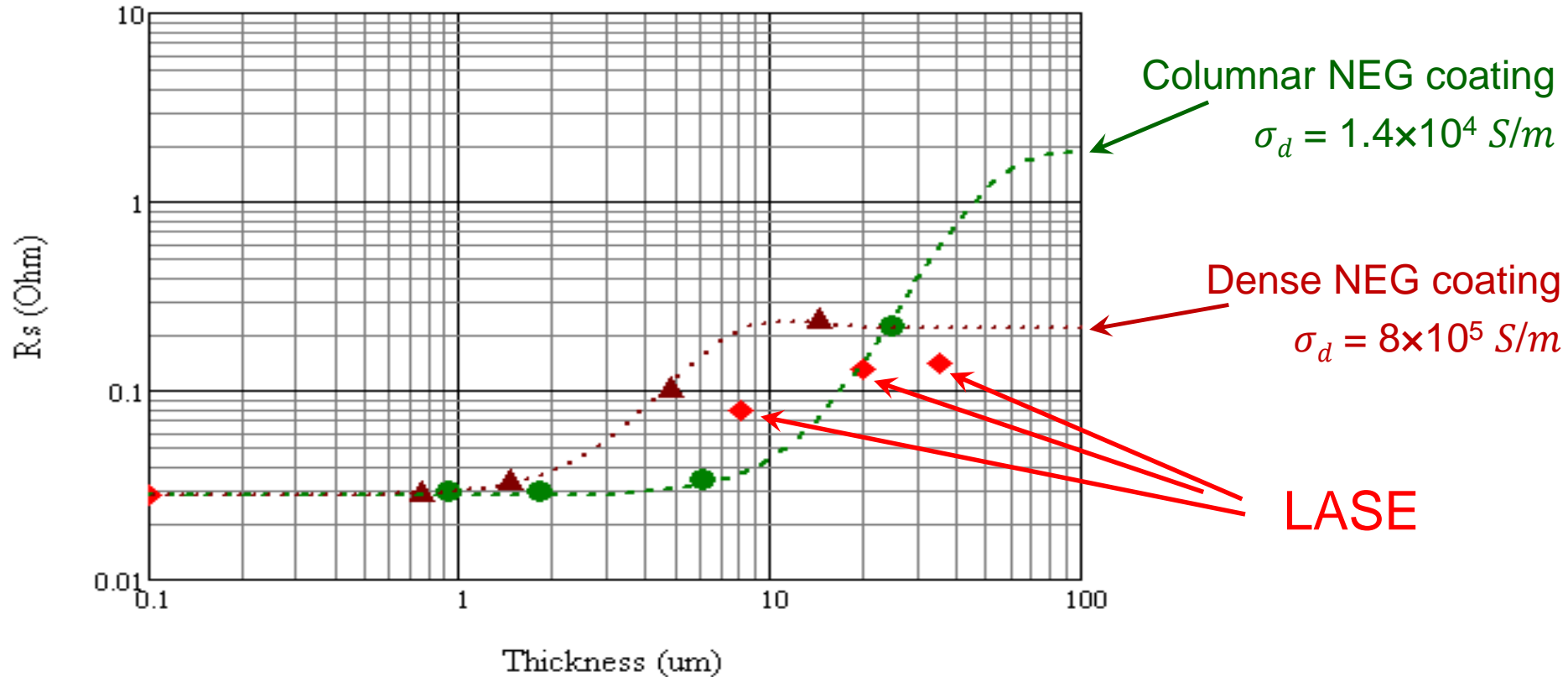
$$R_S^{sam} = \frac{G Q_0^{-1} - R_S^{cav} p_c}{p_s}$$

- The surface resistance of the sample R_S^{sam} can be calculated for known
 - test cavity surface resistances R_S^{cav} and
 - measured Q_0 ,
- The magnetic field distribution in the cavity was calculated using CST Microwave Studio.
 - For our cavity, $G = 235 \Omega$,
 - for perfect electric conductor (PEC) boundary conditions, the field ratios are $p_c = 0.625$ and $p_s = 0.375$.

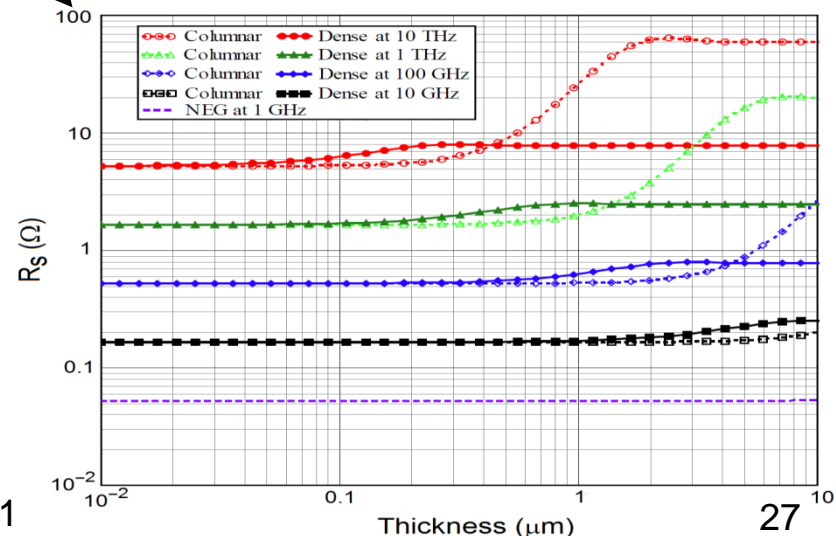
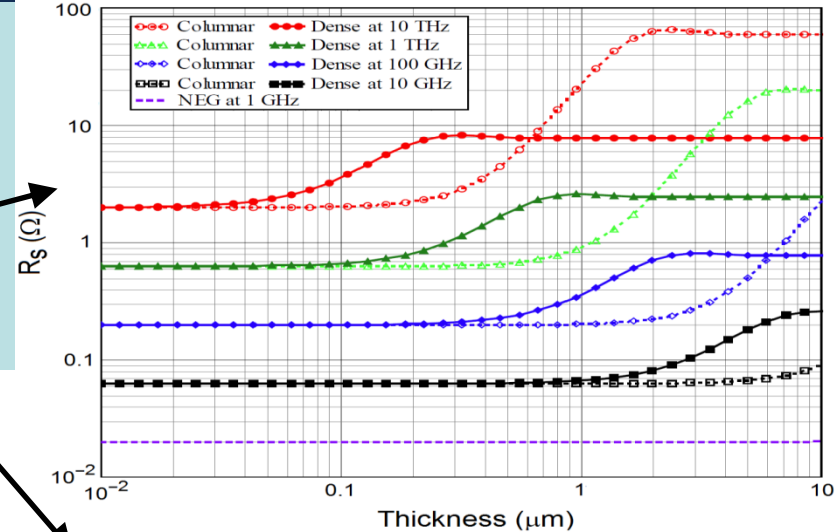
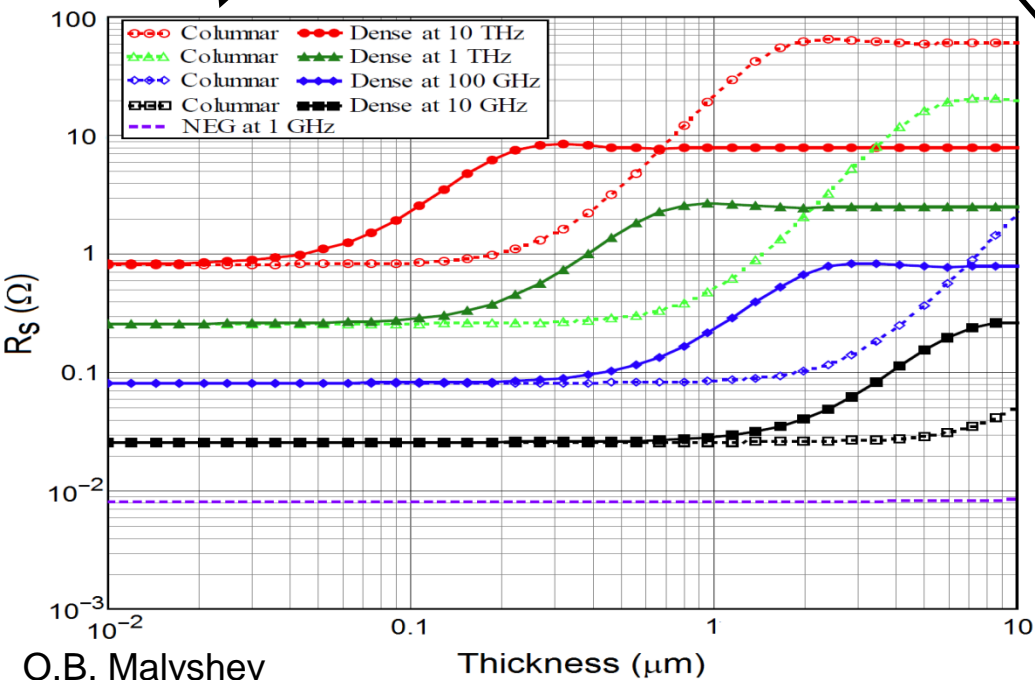




Surface resistance at 7.8 GHz for LASE and NEG coating



NEG coating studies – surface resistance at various frequencies on copper, aluminium and stainless steel





Surface resistance

- A possibility for R_s measurement on a tubular samples on a dedicated facility are under investigation
- An open question:
 - R_s as a function of temperature
 - To be addressed in future
 - Planar samples could be studied in a few months
 - Tubular sample can be considered later



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